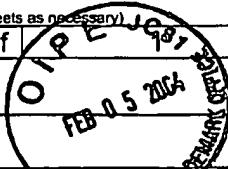


Substitute for form 1449A/PTO & 1449B/PTO			<i>Complete If Known</i>	
FIRST INFORMATION DISCLOSURE STATEMENT BY APPLICANT			Application Number	10/670,556
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			First Named Inventor	Michael STEIGERWALD
			Examiner Name	Unassigned
Sheet	1	of	Attorney Docket Number	007413-067



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101	L. Reimer, "Scanning Electron Microscopy: Physics of Image Formation and Microanalysis," Springer Series in Optical Sciences, pp. 13-19, (1998).		

Examiner Signature	<i>James J. Toland</i>	Date Considered	7/11/04
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.